

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**RECEIVED
CENTRAL FAX CENTER
JUL 30 2007**

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR AND METHOD OF CONTINUOUS HTS TAPE
BUFFER LAYER DEPOSITION USING LARGE SCALE ION BEAM
ASSISTED DEPOSITION

App. No.: 10/609,250

Filed: June 26, 2003

Examiner: Ram N. Kackar

Group Art Unit: 1763

Customer No.: 34456

Confirmation No.: 7760

Atty. Dkt. No.: 1014-SP101-US

MS RCE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN SUPPORT OF RCE

Dear Sir:

In response to the Final Office Action mailed March 28, 2007, please amend the
above-identified application as follows: